

<b>Notice of References Cited</b>	Application/Control No. 10/536,791		Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner CATHERYNE CHEN		Art Unit 1655	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,776,460	07-1998	Kim et al.	424/728
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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	N	JP 6321643	09-1988	Japan	Ishida et al.	-----
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	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
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